

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: **Q84137**

Shinichi ISHIBASHI, et al.

Appln. No.: **National Stage Entry of PCT/JP03/04615**

Confirmation No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: **October 12, 2004**

Examiner: Not yet assigned

For: **REFLECTIVE MASK BLANK, REFLECTIVE MASK AND METHODS OF
PRODUCING THE MASK BLANK AND THE MASK**

SECOND PRELIMINARY AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.